

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No.	:	10/552,497	)	Confirmation No.: 2271
			)	
Applicants:	:	Hansen et al.	)	
			)	
Filed	:	September 8, 2006	)	
			)	
TC/A.U.	:	1792	)	
			)	
Examiner	:	Binh X. Tran	)	
			)	
Docket No.	:	H0027362 9930/95675	)	
			)	
Customer No.	:	00128	)	
			)	
Title	:	METHOD OF MANUFACTURING GAS DIFFUSION ELECTRODES)	)	

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First-Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313, on the date below.

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 FILED VIA U.S. PTO EFS

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 Amy L. Hammer

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 December 22, 2009

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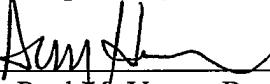
 (Date)
**COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

Applicants appreciate the Examiner's allowance of all of the pending claims in the above-identified application. Applicants respectfully disagree with the Examiner's reasons for allowance to the extent that they are inconsistent with applicable case law, statutes, and regulations. Furthermore, applicants do not admit to any characterization or limitation of the claims or to any characterization of a prior art document by the Examiner, particularly any that is inconsistent with the language of the claims considered in their entirety and including all other constituent limitations.

Respectfully submitted,

By 

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Paul M. Vargo, Reg. No. 29,116  
Amy L. Hammer, Reg. No. 61,048  
HUSCH BLACKWELL SANDERS  
WELSH & KATZ  
120 South Riverside Plaza, 22<sup>nd</sup> Floor  
Chicago, Illinois 0606  
Phone: (312) 655-1500  
Fax: (312) 655-1501

Dated: December 22, 2009